

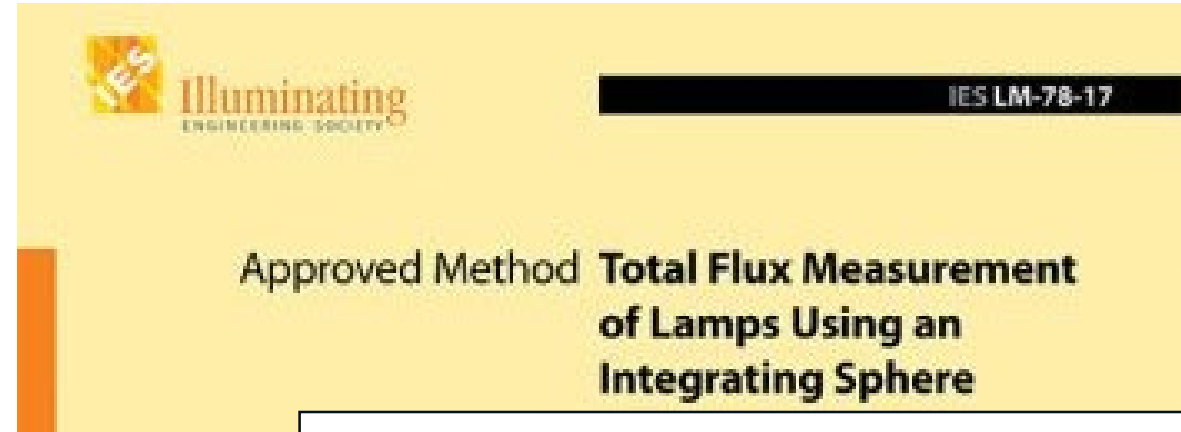
UVC Standards – Physical and Documentary

C. Cameron Miller, Toni Litorja, Thomas Larason,
Yuqin Zong & many others

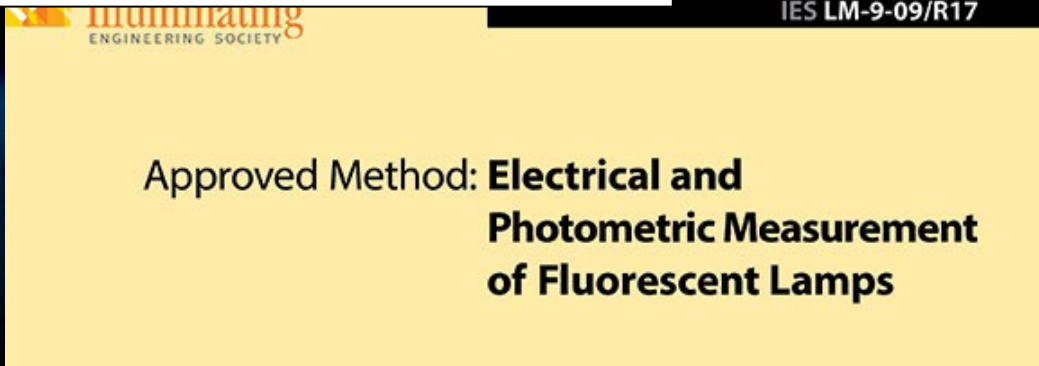
NIST, Sensor Science Division

Discharge Lamps

Low pressure mercury
Medium pressure mercury
Xenon and pulsed xenon
Excimer lamps



LM-75-19 – IES Guide to Goniometer Measurements, Types, and Photometric Coordinate Systems



Measurement quantities:
Total radiant flux (W) or (W/nm)
Radiant intensity distribution (W/sr)
Electrical power (W)

Method for the Measurement of the Output of Monochromatic (254 nm) Low-Pressure UV Lamps[#]

Contributing authors on the IUVA Manufacturers' Council
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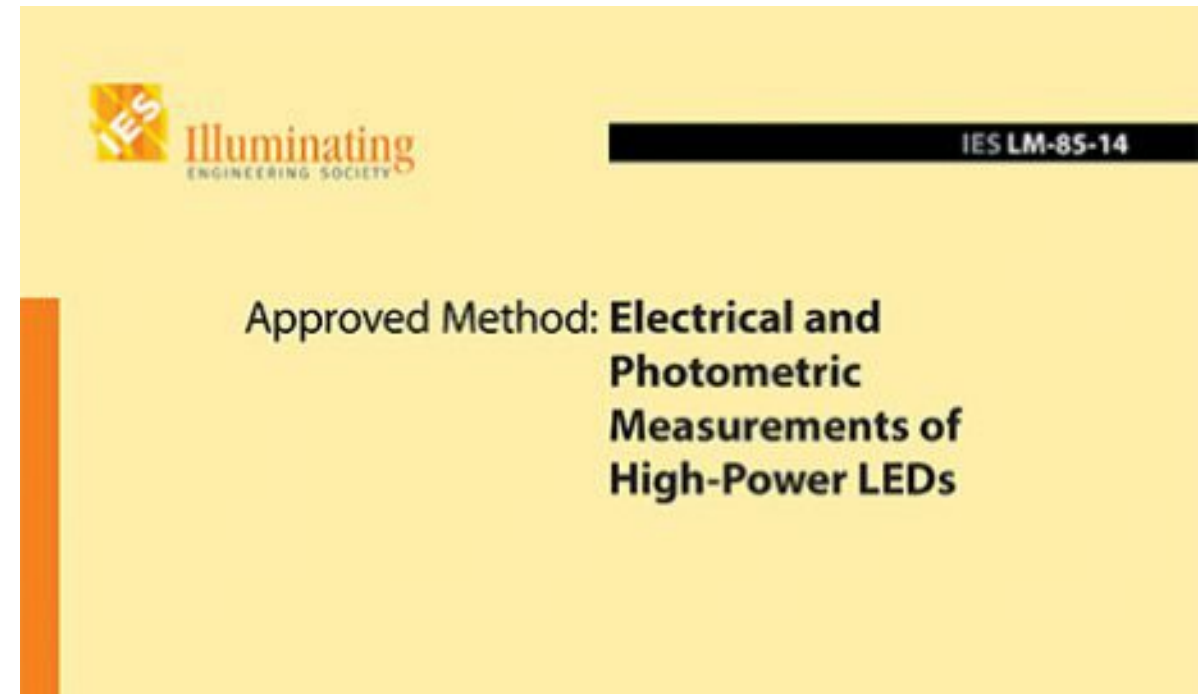
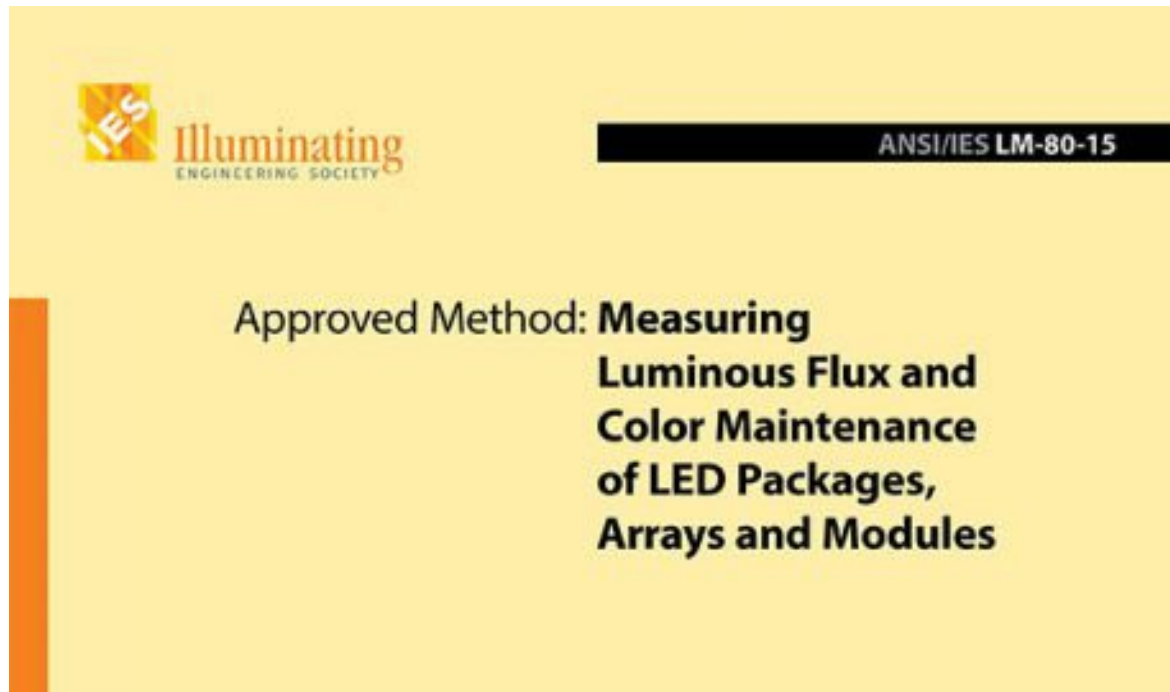
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LED Chips and Arrays

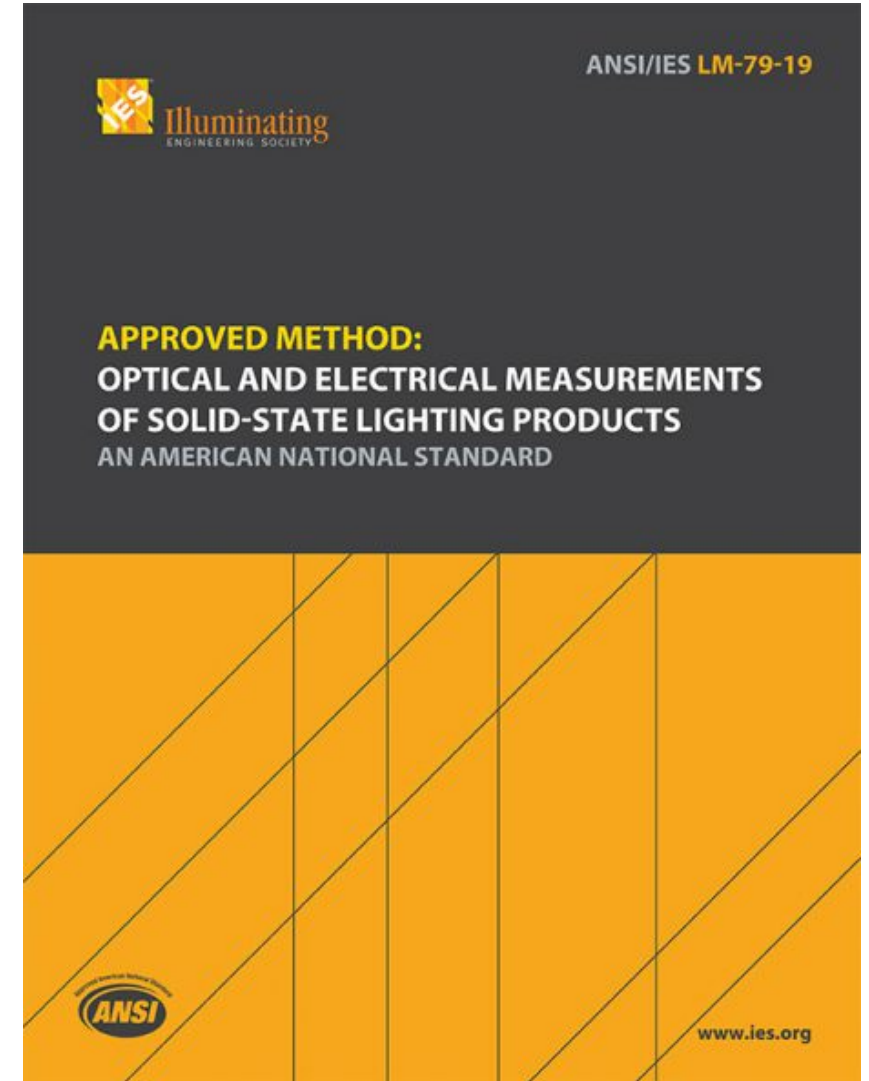
Leverage existing standards
Extension of existing infrastructure



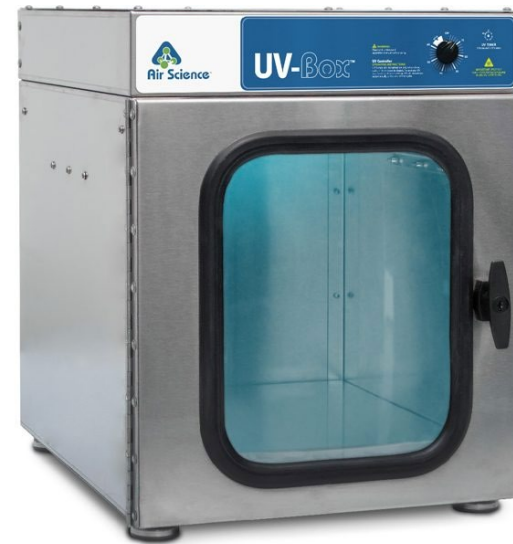
Electrical and Optical
Radiant power maintenance

Complete UV Devices

Leverage existing standards
Extension of existing infrastructure



UV Device Irradiance



IES/TPC Project C303-16 - Application Distance Radiometry

This document describes the method for measuring illuminance, irradiance, and/or photon irradiance (i.e., photon flux density) at multiple points on a plane at a specific application distance.

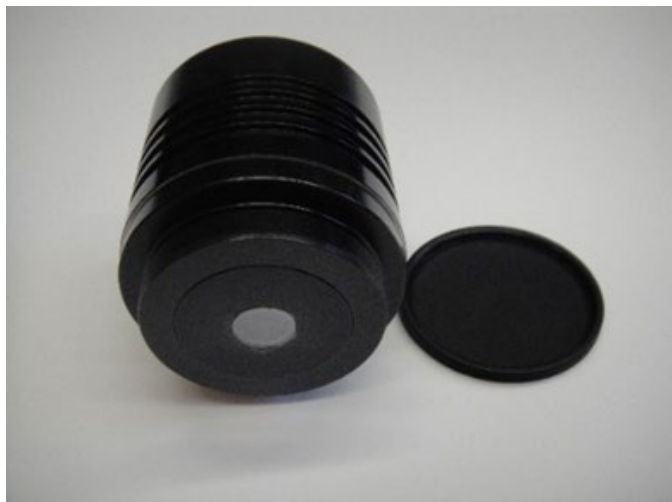


Physical Standards from NIST



Wavelength (nm)	Expanded Uncertainty (k=2) %
200	1.07
250	0.95
300	0.97
350	0.99
400	1.04

Wavelength (nm)	Expanded Uncertainty (k=2) %
250	1.74
350	1.27
450	0.91
555	0.77
900	0.57



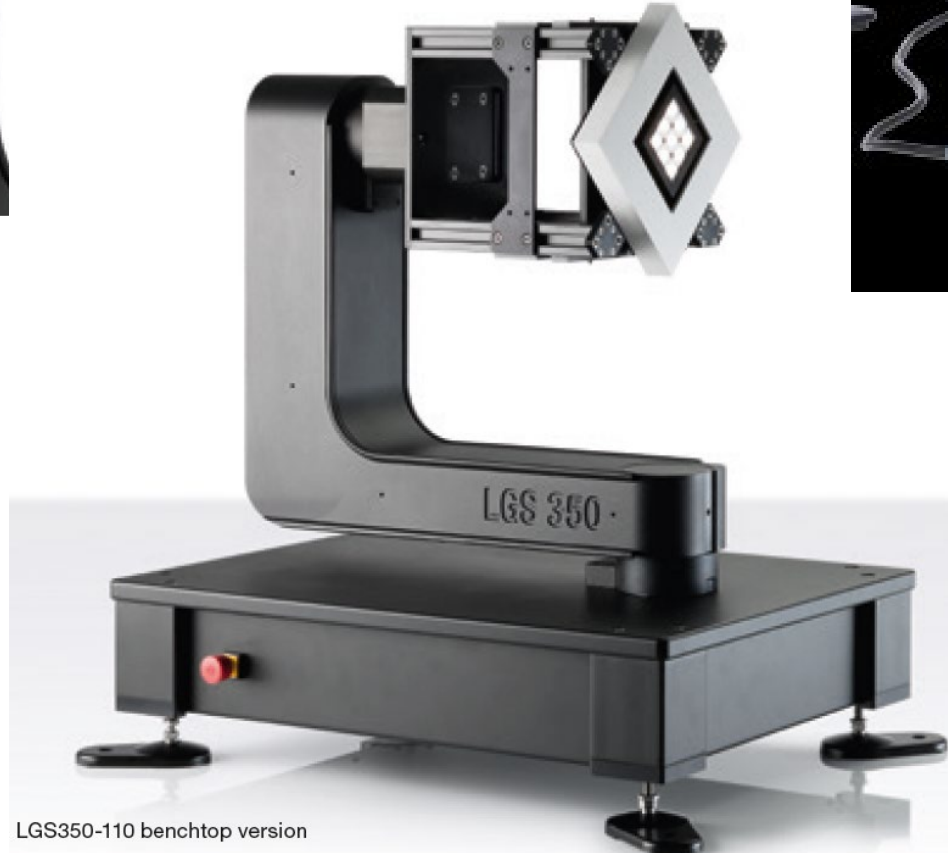
Wavelength (nm)	Expanded Uncertainty (k=2) %
200	4.7
250	1.8
300	1.0
350	0.82
400	0.60

?



UVC Chip & Array Calibration Facility

NIST



LGS350-110 benchtop version

IES LM-85-14 “Approved Method:
Electrical and Photometric
Measurements of High-Power LEDs”

UVC Source Measurement Facility

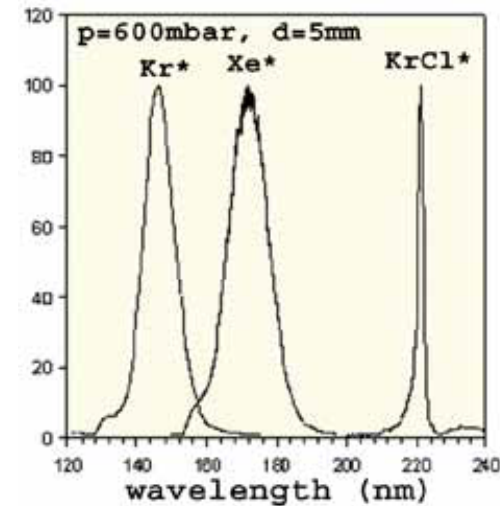
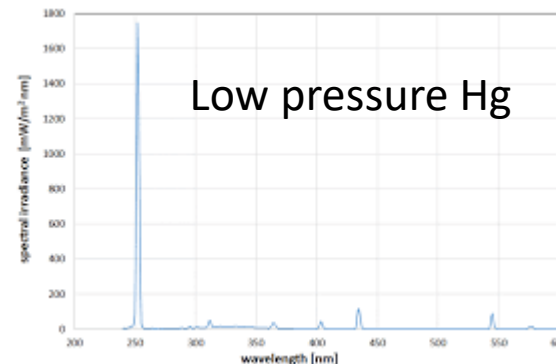
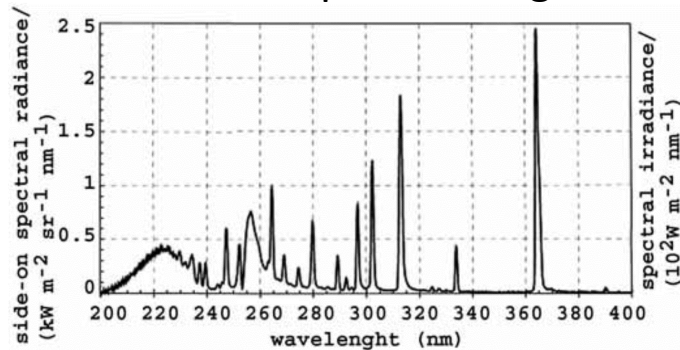


1.5 m sphere system coated with a PTFE film intended for UV water reactors

Spectroradiometer detection

Sources and small products

Medium pressure Hg



ArF*, KrCl*, KrF*, XeBr*, XeCl*, XeF*, emit at 193, 222, 248, 282, 308, 351 nm

Keitz Formula (1971)

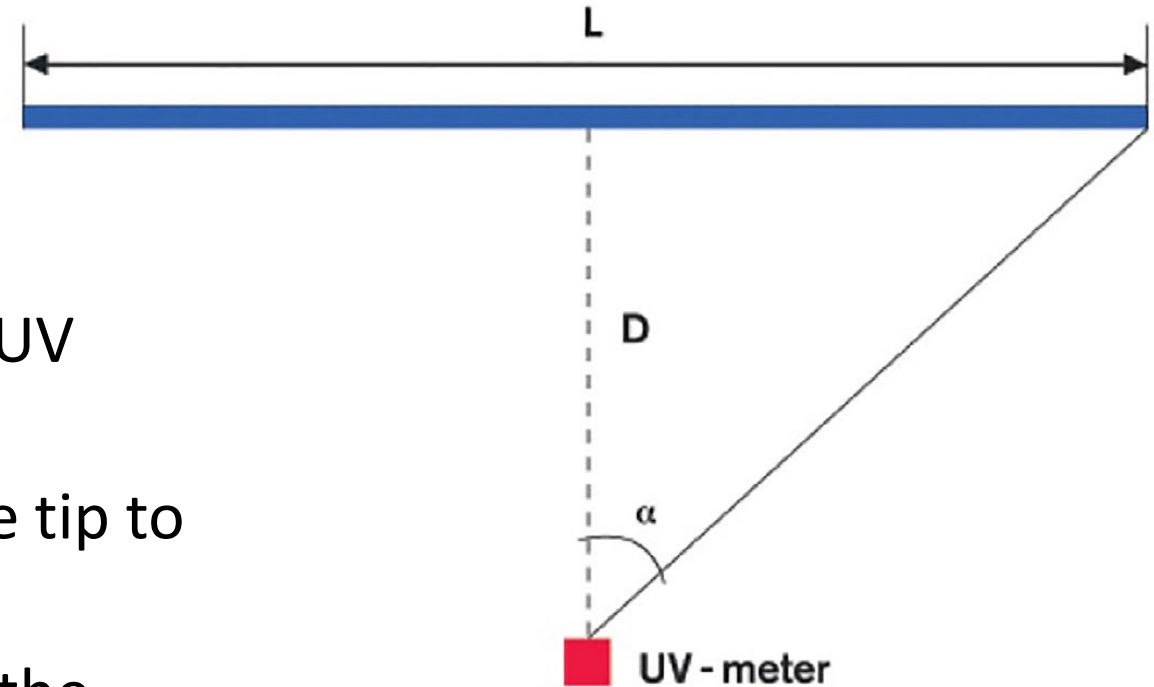
$$P = \frac{E 2 \pi^2 D L}{2 \alpha + \sin 2 \alpha}$$

E is measured irradiance ($\text{W}\cdot\text{m}^{-2}$)

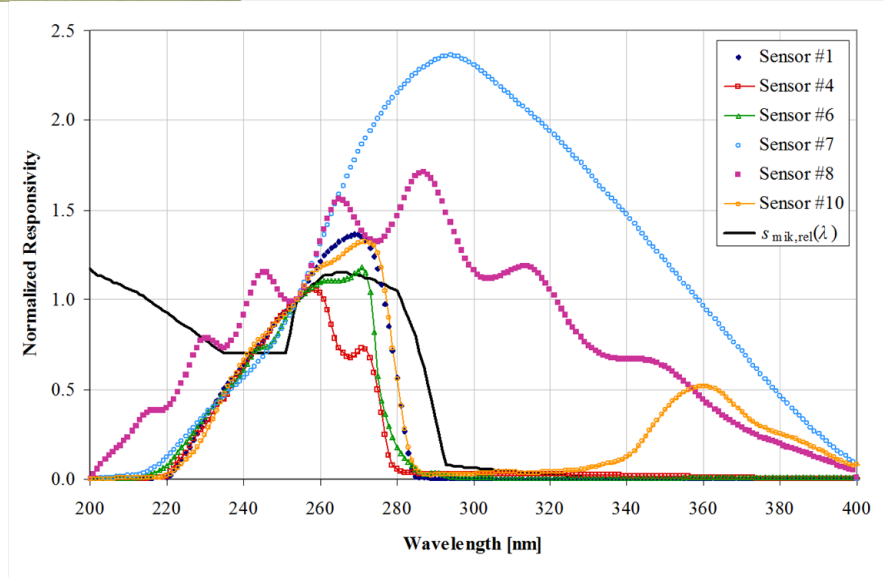
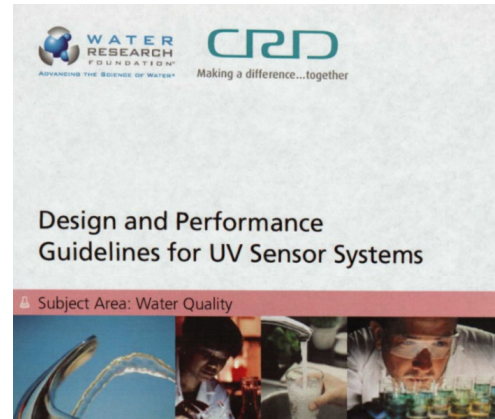
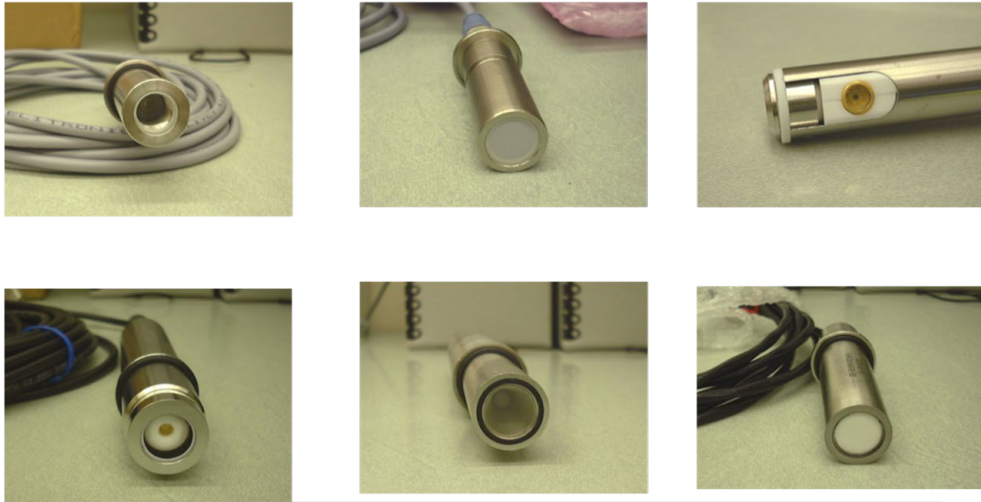
D is distance (m) from lamp center to the UV sensor.

L is the lamp arc length (m) from electrode tip to electrode tip.

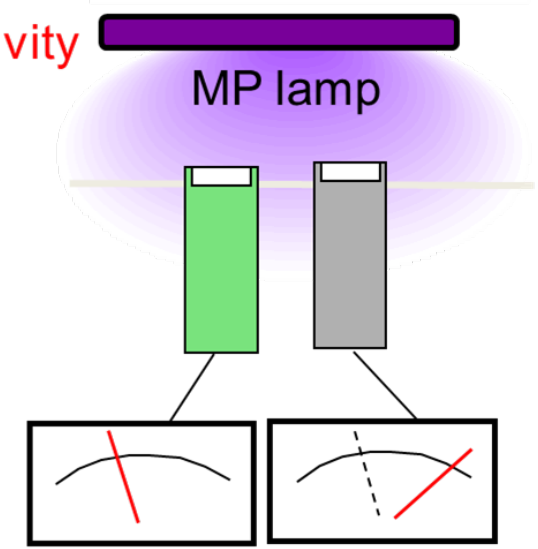
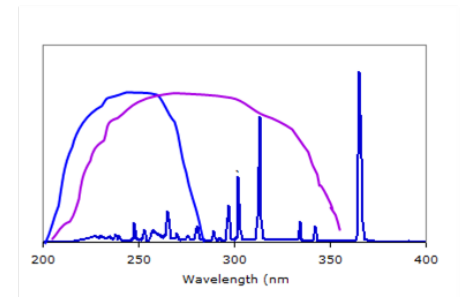
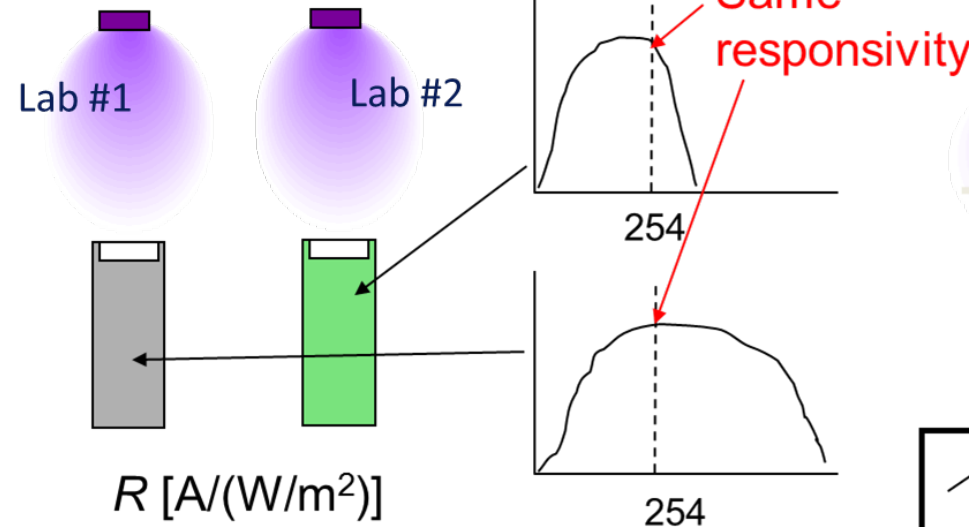
α is the half angle (radians) subtended by the lamp at the sensor position. That is, $\tan \alpha = L/(2D)$



UVC Detector Measurement Facility



LP calibration lamp



NIST Accreditation & Proficiency Testing



Leverage previous experience

- National Voluntary Laboratory Accreditation Program (NVLAP)
- NIST Measurement Assurance Program (MAP)

NIST Handbook 150-1-2019

NVLAP
Energy Efficient
Lighting Products

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Standards Coordination Office
Laboratory Programs*

Dana Leaman
*Standards Services
Standards Coordination Office
Laboratory Programs*

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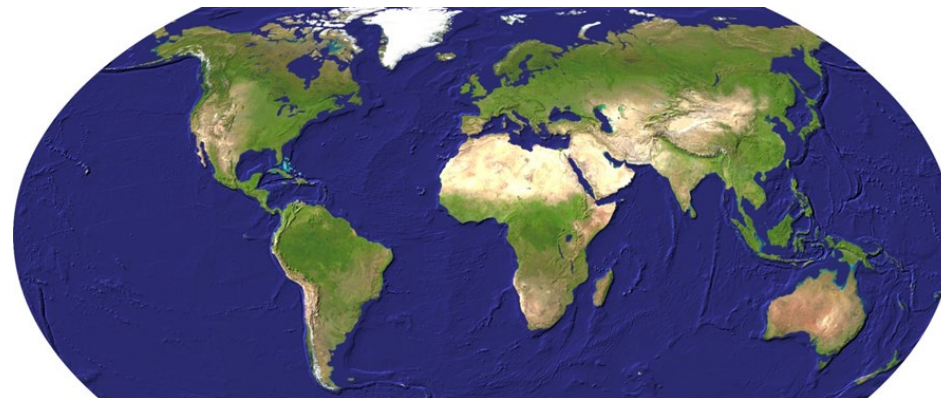
February 2019



U.S. Department of Commerce
Wilbur L. Ross, Jr., Secretary

National Institute of Standards and Technology
Walter Copan, NIST Director and Under Secretary of Commerce for Standards and Technology

- MAP 1: 118 Laboratories worldwide
Jan 2010 – Dec 2014
- MAP 2: 128 Laboratories worldwide
Jan 2015 – Dec 2020



Memorandum of Understanding

International Ultraviolet Association (IUVA)

Illuminating Engineering Society (IES)

Four documentary standard topics

Total radiant flux and radiant intensity distribution measurement of discharge sources;

Total radiant flux and radiant intensity distribution measurement of LED chips and arrays;

Total radiant flux and radiant intensity distribution of complete UV devices; and

Application distance radiometry of UVC devices

NIST continues to improve infrastructure to support documentary standard development